

Docket No.: 063979-0027



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Customer Number: 20277

Gaku SUGAHARA, et al.

Confirmation Number: 3885

Application No.: 10/611,851

Group Art Unit: 2828

Filed: July 03, 2003

Examiner: James A. Menefee

For: NITRIDE SEMICONDUCTOR LASER DEVICE AND FABRICATING METHOD
THEREOF

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated August 30, 2005, having a three-month shortened statutory period for response set to expire November 30, 2005, and the petition for a one-month extension of time up to and including December 30, 2005 being filed concurrently herewith, reconsideration of the above-identified application is respectfully requested in view of the following amendment and remarks.